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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/970,404	10/03/2001	Kan-Yin Ng	MEMC 2987 (00-2950)	9398
321	7590	01/06/2004	EXAMINER	
SENNIGER POWERS LEAVITT AND ROEDEL ONE METROPOLITAN SQUARE 16TH FLOOR ST LOUIS, MO 63102				DANG, PHUC T
ART UNIT		PAPER NUMBER		
		2818		

DATE MAILED: 01/06/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

	Application No.	Applicant(s)
	09/970,404	NG ET AL.
	Examiner	Art Unit
	PHUC T DANG	2818

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 2 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1) Responsive to communication(s) filed on 12 December 2002.

2a) This action is **FINAL**. 2b) This action is non-final.

3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4) Claim(s) 1-18 is/are pending in the application.

4a) Of the above claim(s) 8-18 is/are withdrawn from consideration.

5) Claim(s) _____ is/are allowed.

6) Claim(s) _____ is/are rejected.

7) Claim(s) 1-7 is/are objected to.

8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on 03 October 2001 is/are: a) accepted or b) objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. §§ 119 and 120

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) All b) Some * c) None of:
1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. _____.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

13) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.
a) The translation of the foreign language provisional application has been received.

14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.

Attachment(s)

1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413) Paper No(s). _____.
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 5) Notice of Informal Patent Application (PTO-152)
3) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 0102 & 120 6) Other: _____

Art Unit: 2818

DETAILED ACTION

Oath/Declaration

1. The oath/declaration filed on October 3, 2001 is acceptable.

Election/Restrictions

2. Applicant's election without traverse of Group I (claims 1-7) drawn to a process of forming a semiconductor wafer is acknowledged for prosecution in the subject application. Applicants have the right to file a divisional application covering the subject matter of the non-elected claims.

Information Disclosure Statement

3. The office acknowledges receipt of the following items from the applicant:

Information Disclosure Statement (IDS) filed on January 3, 2002 and December 12, 2002.

Specification

This application is in condition for allowance except for the following formal matters:

- i) The specification is objected to for the following reason:

The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed (see MPEP 606.01).

A title such as – METHOD OF PRODUCING POLISHED SEMICONDUCTOR WAFERS – is suggested. Note that, the claims are directed to method of making a semiconductor device instead of to an apparatus of a semiconductor device.

- ii) The claims 1-7 are objected to because of the following reason:

In claim 1, lines 9-10, a term “wax” should change to – the layer of wax --.

Art Unit: 2818

Allowable Subject Matter

4. Claims 1-7 are allowed.

Examiner will consider claims 1-7 would be allowed if Applicants cancel the non-elected claims of Group II (claims 8-18) upon responding to the next Office action.

The following is a statement of reason for the indication of allowable subject matter:

Claims are considered allowable since the prior art of record and the considered pertinent to the applicant's disclosure does not teach or suggest a process of forming a semiconductor wafer which inhibits the formation of surface features on a polished front side of the wafer, the process comprising a step of mounting the semiconductor wafer on the mounting surface of the polishing block, the step of mounting including the steps of holding the wafer in an undeflected position, dropping the undeflected wafer so that a backside of the wafer contacts the layer of the wax, and inflating a bladder to press the wafer into the wax and remove air from between the wafer and the polishing block in the wax.

Prosecution on the merit is closed in accordance with the practice under Ex Parte Quayle, 1935 C.D. 11, 453 O.G. 213.

A shortened statutory period for reply to this action is set to expire **TWO MONTHS** from the mailing date of this letter.

When responding to the Office action, Applicants' are advised to provide the Examiner with the line numbers and page numbers in the application and/or references cited to assist the Examiner the appropriate paragraphs.

Art Unit: 2818

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Phuc T. Dang whose telephone number is 703-305-1080. The examiner can normally be reached on 8:00 am-5:00 pm.

6. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David C. Nelms can be reached on 703-308-4910. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-5841 for After Final communications.

7. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

Phuc T. Dang ^{PD}
Primary Examiner



Art Unit 2818

December 31, 2003